

Docket No.: 065326-0029

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
	:	
Yasushi SASA, et al.	:	Confirmation Number: 9832
	:	
Application No.: 10/657,107	:	Group Art Unit: 2624
	:	
Filed: September 09, 2003	:	Examiner: Alex Kok Soon LIEW
	:	
For: DEFECT INSPECTION APPARATUS, DEFECT INSPECTION METHOD AND PROGRAM		

**RESPONSE**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 26, 2007, having a three-month shortened statutory period for reply set to expire on March 26, 2008, a petition for a one month extension of time up to and including April 26, 2008 being filed concurrently herewith, please amend the above identified application as follows.

Remarks begin on page 2.